

L Number	Hits	Search Text	DB	Time stamp
1	2	NG-HUNG-YIP-.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/02 18:22
2	2	("20020164546").PN.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/02 18:22
4	4272	(isolated sparse sparsely) near (feature pattern)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/02 18:34
6	4165	(nested packed closely dense densely) near (feature pattern)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/02 18:35
3	907	BROWN-JEFFREY-J-.in. BROWN-J-J-.in. BROWN-J-JAMES-.in. DESHPANDE-S-.in. DESHPANDE-SADANAND-VINAYAK-.in. DESHPANDE-S-V-.in. HORAK-DAVID-.in. HORAK-DAVID-V-.in. HORAK-DAVID-VACLAV-.in. HORAK-DAVID-VACLAY-.in. HORAK-D-V-.in. SURENDRA-M-.in. SURENDRA-MAHESWARAN-.in. TSOU-L-Y-.in. TSOU-LEN-.in. TSOU-LEN-Y-.in. TSOU-LEN-YAN-.in. TSOU-LEN-YUAN-.in. YANG-QINGYUN-.in. YU-CHIENFAN-.in. ZHANG-YING-.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/02 18:39
7	12878	430/30,313,311,316,317,329.ccls. 438/714,725.ccls. 216/49,59,67.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/02 18:39
8	724439	resist photoresist photo-resist photosensitive photo-sensitive (sensitive near (photo light radiation energy))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/03/02 18:41
9	16560	etch\$5 near3 (trim\$5 shrink\$3 reduction reduc\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/03/02 18:42
10	766733	oxygen o2 "o.sub.2"	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/03/02 18:42
11	758139	nitrogen n2 "n.sub.2"	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/03/02 18:42
12	25727	etch\$5 near3 (trim\$5 shrink\$3 reduction reduc\$3 adjust\$3 small\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/03/02 18:43
13	2412	(oxygen o2 "o.sub.2") with (nitrogen n2 "n.sub.2") with etch\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/03/02 18:44
14	117	(430/30,313,311,316,317,329.ccls. 438/714,725.ccls. 216/49,59,67.ccls.) and ((isolated sparse sparsely) near (feature pattern)) and ((nested packed closely dense densely) near (feature pattern))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/03/02 18:46

15	390	(430/30,313,311,316,317,329.ccls. 438/714,725.ccls. 216/49,59,67.ccls.) and ((oxygen o2 "o.sub.2") with (nitrogen n2 "n.sub.2") with etch\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/02 18:50
16	22	(resist photoresist photo-resist photosensitive photo-sensitive (sensitive near (photo light radiation energy))) with etch\$5 with ((isolated sparse sparsely) near (feature pattern)) with ((nested packed closely dense densely) near (feature pattern))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/02 18:55
17	76152	(tuning tunable adjust\$6) near2 (parameter condition)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/02 18:56
18	24791	rf near power	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/02 18:56
19	1	((tuning tunable adjust\$6) near2 (parameter condition)) (rf near power)) with etch\$6 with ((isolated sparse sparsely) near (feature pattern)) with ((nested packed closely dense densely) near (feature pattern))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/02 18:56
20	2	((tuning tunable adjust\$6) near2 (parameter condition)) (rf near power)) with etch\$6 with (((isolated sparse sparsely) near (feature pattern)) ((nested packed closely dense densely) near (feature pattern)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/02 18:57
21	9	((tuning tunable adjust\$6) near2 (parameter condition)) (rf near power)) with (((isolated sparse sparsely) near (feature pattern)) ((nested packed closely dense densely) near (feature pattern)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/02 18:58
23	68	etch\$4 with (((isolated sparse sparsely) near (feature pattern)) with ((nested packed closely dense densely) near (feature pattern)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/02 19:07
24	6	(resist photoresist photo-resist photosensitive photo-sensitive (sensitive near (photo light radiation energy))) with (etch\$5 near3 (trim\$5 shrink\$3 reduction reduc\$3 adjust\$3 small\$3)) with (((isolated sparse sparsely) near (feature pattern)) ((nested packed closely dense densely) near (feature pattern)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/02 19:08
25	23	(etch\$5 near3 (trim\$5 shrink\$3 reduction reduc\$3 adjust\$3 small\$3)) with (((isolated sparse sparsely) near (feature pattern)) ((nested packed closely dense densely) near (feature pattern)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/02 19:09
26	17	((etch\$5 near3 (trim\$5 shrink\$3 reduction reduc\$3 adjust\$3 small\$3)) with (((isolated sparse sparsely) near (feature pattern)) ((nested packed closely dense densely) near (feature pattern)))) not ((resist photoresist photo-resist photosensitive photo-sensitive (sensitive near (photo light radiation energy))) with (etch\$5 near3 (trim\$5 shrink\$3 reduction reduc\$3 adjust\$3 small\$3)) with (((isolated sparse sparsely) near (feature pattern)) ((nested packed closely dense densely) near (feature pattern))))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/02 19:08

27	64	(etch\$5 near3 (trim\$5 shrink\$3 reduction reduc\$3 adjust\$3 small\$3)) with (oxygen o2 "o.sub.2") with (nitrogen n2 "n.sub.2")	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/03/02 19:11
29	6	(trim\$4) with etch\$5 with (oxygen o2 "o.sub.2") with (nitrogen n2 "n.sub.2")	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/03/02 19:14
30	6	((("6376308") or ("6168993") or ("6107172"))).PN.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/02 19:14
32	2	((("6376308") or ("6168993") or ("6107172"))).PN.) and (flow ratio rf power pressure mtorr millitorr torr watt)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/02 19:24
33	2	((("6376308") or ("6168993") or ("6107172"))).PN.) and (flow ratio rf power pressure mtorr millitorr torr watt) and (oxygen o2 "o.sub.2") and (nitrogen n2 "n.sub.2")	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/02 19:18
34	62	((etch\$5 near3 (trim\$5 shrink\$3 reduction reduc\$3 adjust\$3 small\$3)) with (oxygen o2 "o.sub.2") with (nitrogen n2 "n.sub.2")) not ((trim\$4) with etch\$5 with (oxygen o2 "o.sub.2") with (nitrogen n2 "n.sub.2"))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/02 19:23
35	1	us-6074566-\$.did. and (flow ratio rf power pressure mtorr millitorr torr watt)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/02 19:27
36	1	us-6074566-\$.did. and (etch\$5 near3 (trim\$5 shrink\$3 reduction reduc\$3 adjust\$3 small\$3))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/02 19:28
37	12	((("6372651") or ("6107172") or ("6283131") or ("5940719") or ("6235440") or ("20010009792") or ("50211121") or ("20020139773") or ("6482726") or ("20020142252") or ("6368982") or ("20020164546") or ("20020142252") or ("6233388"))).PN.	USPAT; US-PGPUB	2004/03/02 19:29
38	2	((("6372651") or ("6107172") or ("6283131") or ("5940719") or ("6235440") or ("20010009792") or ("50211121") or ("20020139773") or ("6482726") or ("20020142252") or ("6368982") or ("20020164546") or ("20020142252") or ("6233388"))).PN.) and ((isolated sparse sparsely) near (feature pattern)) and ((nested packed closely dense densely) near (feature pattern))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/02 19:30
39	7	((("6372651") or ("6107172") or ("6283131") or ("5940719") or ("6235440") or ("20010009792") or ("50211121") or ("20020139773") or ("6482726") or ("20020142252") or ("6368982") or ("20020164546") or ("20020142252") or ("6233388"))).PN.) and (oxygen o2 "o.sub.2") and (nitrogen n2 "n.sub.2")	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/02 19:34
5	70	(across adj chip adj (linewidth line-width line adj width) adj variation) aclv!	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/02 20:11
42	12	((across adj chip adj (linewidth line-width line adj width) adj variation) aclv!) and (((isolated sparse sparsely) near (feature pattern)) ((nested packed closely dense densely) near (feature pattern)))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/02 19:38